

Attorney Docket No. 040008-0307458
Client Reference: OG03-025

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: JIN HYO JUNG

Application No.:	Confirmation No:
Filed: December 30, 2003	Group No.:
	Examiner
For: METHOD FOR FABRICATING FLASH MEMORY DEVICE	

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

APPLICATION DATA SHEET
37 C.F.R. § 1.76

BIBLIOGRAPHIC DATA

1. Applicant information

First applicant: JIN HYO JUNG
Citizenship: Republic of Korea
Residence: Bucheon-si, Gyeonggi-do, Korea

2. Correspondence information

Correspondence for this application should be addressed as follows:

Customer No.: 00909

3. Application information

Title of Invention: METHOD FOR FABRICATING FLASH MEMORY DEVICE

Docket number assigned to this application: 040008-0307458

Suggested Classification: Class:

Subclass:

Technology Center to which subject matter is assigned:

Total number of drawing sheets: 4

Type of application: Utility

Application is to be published. Suggested drawing figure for publication:

Secrecy order under § 5.2:

This application does not disclose subject matter of an application which is under a secrecy order pursuant to § 5.2.

4. Representative information

The following have a power of attorney or authorization of agent in this application:

Customer No.: 00909

5. Foreign priority information

Foreign priority is claimed for this application as follows:

Country: Republic of Korea
Application No.: 10-2003-0069217
Filing Date: October 6, 2003
Status: Pending

6. Assignee information

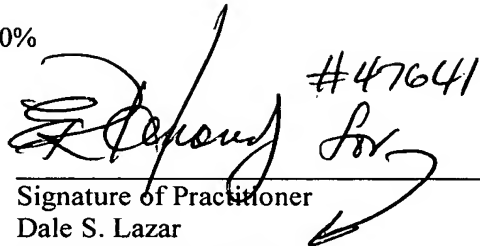
The assignee(s) of this application is/are:

Anam Semiconductor Inc.
891-10 Daechi-dong, Gangnam-gu
Seoul, 135-523
Korea

Extent of interest of assignee in application: 100%

Date: December 30, 2003

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